

PATENT ASSIGNMENT COVER SHEET

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Stylesheet Version v1.2

EPAS ID: PAT7363540

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
CHEN-FU CHU	05/26/2022
SHIH-KAI CHAN	05/26/2022
YI-FENG SHIH	05/26/2022
DAVID TRUNG DOAN	05/26/2022
TRUNG TRI DOAN	05/26/2022
YOSHINORI OGAWA	05/26/2022
KOHEI OTAKE	05/27/2022
KAZUNORI KONDO	05/27/2022
KEIJI OHORI	05/27/2022
TAICHI KITAGAWA	05/27/2022
NOBUAKI MATSUMOTO	05/29/2022
TOSHIYUKI OZAI	05/27/2022
SHUHEI UEDA	05/27/2022
RECEIVING PARTY DATA	
Name:	SEMILEDS CORPORATION
Street Address:	1F, NO. 11, KE JUNG RD., CHU-NAN SITE
Internal Address:	HSINCHU SCIENCE PARK
City:	CHU-NAN, MIAO-LI COUNTY
State/Country:	TAIWAN
Postal Code:	350
Name:	SHIN-ETSU CHEMICAL CO., LTD.
Street Address:	20TH FLOOR, MARUNOUCHI EIRAKU BLDG.,
Internal Address:	4-1, MARUNOUCHI 1-CHOME, CHIYODA-KU
City:	TOKYO
State/Country:	JAPAN
Postal Code:	100-0005
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	17740729

CORRESPONDENCE DATA**Fax Number:** (303)989-6353*Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.***Phone:** 3039896353**Email:** steve@grattonlaw.com**Correspondent Name:** STEPHEN A. GRATTON**Address Line 1:** 2764 SOUTH BRAUN WAY**Address Line 4:** LAKEWOOD, COLORADO 80228**ATTORNEY DOCKET NUMBER:** TSLC/SHINETSU2019-002.01C**NAME OF SUBMITTER:** STEPHEN A. GRATTON**SIGNATURE:** /STEPHEN A. GRATTON/**DATE SIGNED:** 06/03/2022**Total Attachments: 14**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

CHEN-FU CHU
SHIH-KAI CHAN
YI-FENG SHIH
DAVID TRUNG DOAN
TRUNG TRI DOAN
YOSHINORI OGAWA
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TAICHI KITAGAWA
NOBUAKI MATSUMOTO
TOSHIYUKI OZAI
SHUHEI UEDA

Serial No.: 17/740,729

Filing Date: 05/10/2022

Title: **METHOD FOR FABRICATING (LED) DICE USING
SEMICONDUCTOR STRUCTURES ON A SUBSTRATE
AND A LASER LIFT-OFF TO A RECEIVING PLATE**

Docket No. TSLC&SHIN-ETSU/2019-002.01C/US

ASSIGNMENT:

 x Enclosed for recording
____ Previously recorded
Date: _____
Reel: _____

ASSIGNMENT

FOR GOOD AND VALUABLE CONSIDERATION, the receipt, sufficiency, and adequacy of which are hereby acknowledged, the undersigned do hereby:

SELL, ASSIGN, AND TRANSFER to SemiLEDs Corporation a Delaware corporation, with its business address at 1F, No. 11, Ke Jung Rd., Chu-Nan Site, Hsinchu Science Park, Chu-nan 350, Miao-Li County, Taiwan, R.O.C. and SHIN-ETSU CHEMICAL CO., LTD., a Japanese company with its business address at 20th Floor (Reception), Marunouchi Eiraku Bldg., 4-1, Marunouchi 1-chome, Chiyoda-ku, Tokyo

100-0005, Japan (the "Assignees), the entire right, title, and interest for the United States and all foreign countries, in and to any and all improvements which are disclosed in the application for United States Letters Patent, which will be executed by the undersigned and is entitled **METHOD FOR FABRICATING (LED) DICE USING SEMICONDUCTOR STRUCTURES ON A SUBSTRATE AND LASER LIFT-OFF TO A RECEIVING PLATE**; such application and all divisional, continuing, substitute, renewal, reissue, and all other applications for patent which have been or shall be filed in the United States and all foreign countries on any of such improvements; all original and reissued patents which have been or shall be issued in the United States and all foreign countries on such improvements; and specifically including the right to file foreign applications under the provisions of any convention or treaty and claim priority based on such application in the United States of America;

AUTHORIZE AND REQUEST, the issuing authority to issue any and all United States and foreign patents granted on such improvements to the Assignee;

WARRANT AND COVENANT that no assignment, grant, mortgage, license, or other agreement affecting the rights and property herein conveyed has been or will be made to others by the undersigned, and that the full right to convey the same as herein expressed is possessed by the undersigned;

COVENANT that, when requested and at the expense of the Assignee, to carry out in good faith the intent and purpose of this assignment the undersigned will execute all divisional, continuing, substitute, renewal, reissue, and all other patent applications on any and all such improvements; execute all rightful oaths, declarations, assignments, powers of attorney, and other papers; communicate to the Assignee all facts known to the undersigned relating to such improvements and the history thereof; and generally do everything possible which the Assignee shall consider desirable for securing, maintaining, and enforcing proper patent protection for such improvements and for vesting title to such improvements in the Assignee;

TO BE BINDING on the heirs, assigns, representatives, and successors of the undersigned and extend to the successors, assigns, and nominees of the Assignee.

Signature:

Chen-Fu Chu

Date 2022/5/26

CHEN-FU CHU

Signature:

Shih Kai Chan

Date

2022.5.26

SHIH-KAI CHAN

Signature:

YI-FENG SHIH

Date 2022.05.26

YI-FENG SHIH

Signature:



Date

2022-05-26

DAVID TRUNG DOAN

Signature:


TRUNG TRI DOAN

Date 2022-05-26

Signature:

 Date May 26, 2022
YOSHINORI OGAWA

Signature:

Kohei Otake

Date

May 17, 2022

KOHEI OTAKE

Signature:

Kazunori Kondo Date May 27, 2022
KAZUNORI KONDO

Signature:

K. Ohori
KEIJI OHORI

Date *May 27, 2022*

Signature:

Taichi Kitagawa
TAICHI KITAGAWA

Date May. 27. 2022

Signature:

NOBUAKI MATSUMOTO
NOBUAKI MATSUMOTO

Date *May, 27, 2022*

Signature:

Toshiyuki Ozai Date May. 27. 2022
TOSHIYUKI OZAI

Signature:

Shuhei Ueda Date May. 27th, 2022
SHUHEI UEDA